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(54) **MANUFACTURE OF SUBSTRATE FOR PLASMA  
DISPLAY PANEL AND FORMING DIE USED  
THEREFOR**

(57) Abstract:

PROBLEM TO BE SOLVED: To provide a manufacturing method of a substrate for a PDP and a forming die therefor, allowing the forming die to be repeatedly used while preventing a base body and ribs from being damaged, and further to provide a manufacturing method of the substrate for a PDP dispensing with a removal process of a rib molding or precursor in peripheral parts of the base body.

SOLUTION: This manufacturing method for a plasma display panel substrate installs ribs on a

base body. A rib precursor, including a first photo-curing initiator with a first absorption edge and a first photo-curing constituent, is stuck fast to the base body, and a second photo-curing constituent is photo-cured in the existence of a second photo-curing initiator with a second adsorption edge of a wavelength shorter than the wavelength corresponding to the first absorption edge of the first photo-curing initiator. A forming die so obtained is filled with the rib precursor, the rib precursor is cured by being irradiated with light of a wavelength shorter than the wavelength corresponding to the second absorption edge, and the forming die is removed.

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